# Deconvolution of Atomic Force Microscopy Data From the Effects of Destructive Indentation and Rigid **Body Motion of Embedded Particles In Heterogeneous Systems**

#### **Research Question/Motivation**

- Atomic Force Microscopy (AFM) used by researchers to characterize soft materials at micron and submicron length scales
- Experimental AFM data is easily convoluted by many structural effects
- Investigate/study the effects of destructive indentation and rigid body motion of embedded particles on AFM data



Figure 1 Destructive AFM indentation causing material damage (plasticity) to a soft polymer matrix and rigid body motion undergone by embedded hard particles under indentation load

### Methods

- **AFM** Peak Force Quantitative Nanomechanics Mapping (**PFQNM**) on multi-walled carbon nanotubes (MWCNT) and CNT buckypaper to obtain property data
- Finite Element Analysis (FEA)
  - Simulate quasi-static AFM indentation at varying depths on 2D axisymmetric FE polymermatrix model to study the effects of 1) destructive indentation and 2) rigid body motion of particles on force-displacement data

#### **Models/Equations**

Derjaguin-Muller-Toporov (DMT) contact theory

$$E_r = \frac{3(F_{con} + F_{disp})}{4r^{0.5}\delta^{1.5}} \quad E_r^{-1} = \frac{1 - v_{mat}^2}{E_{mat}} + \frac{1 - v_{tip}^2}{E_{tip}}$$

Microscopic yield strength based on Hertz and Tresca (Ikeshima et al., 2019)

$$S_y = 1.09 \left(\frac{F_y E_r^2}{\pi^3 r^2}\right)^{\frac{1}{3}}$$

## Results

B: 0.5 nm Large Def OFF Total Deformation Type: Total Deformation Unit: um Time: 1 s



Figure 2 (a) FEA displacement contour for 0.5 nm indentation displacement control load (at time t = 1 s) and (b) force-displacement curves (loading and retract) for 0.5 nm, 1 nm, and 2 nm (linear and nonlinear geometry) indentation loads alongside the Hertzian force-displacement curve

C: 8 nm Large Def ON Total Deformation Type: Total Deformation Jnit: µm Time: 1 s



- Force-displacement data obtained for 0.5, 1, 2, 4, and 8 nm indentations, plotted alongside Hertzian curve Identified micro(nano)scopic yield threshold,  $S_{y,avg} = 327.25 \pm 0.85$  MPa
- Simulated force-displacement data for linear and nonlinear geometry analyses deviate as indentation depth increases Higher indentation forces for nonlinear geometry
- FE model poorly described by Hertz and DMT at high indentation depth (small strain/small deformation assumption no longer applies)

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Figure 3 (a) FEA displacement contour for 8 nm indentation displacement control load (nonlinear geometry at time t = 1 s) and (b) linear and nonlinear geometry force-displacement curves for 4 nm and 8 nm indentation loads alongside the Hertzian force-displacement curve



